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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP ART UNIT: 2812 *6/1/3*

PATENT APPLICATION
Q-51885 *Surber*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akitaka KIMURA

Appln. No.: 09/161,981

Confirmation No.: 8269

Group Art Unit: 2812

Filed: September 29, 1998

Examiner: Mulpuri, S

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND METHOD FOR
DEPOSITING SEMICONDUCTOR LAYER

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one (1) month, extending the time for responding to the Office Action of November 20, 2002 to March 20, 2003.

A check for the statutory fee of \$110.00 is attached. Please charge any additional fees under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

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110.00 OP

Respectfully submitted,

John H. Mion
John H. Mion
Registration No. 18,879

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
(202) 663-7901

WASHINGTON OFFICE



23373

PATENT TRADEMARK OFFICE
Date: March 20, 2003

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